

Applicant(s): Min-soo Kim, et al.

## **REMARKS**

No new matter is added to the application. Entry is respectfully requested.

Attached hereto is a marked-up version of the changes made to the application by the current Amendment. The attached pages are captioned "Version with Markings to Show Changes Made."

Date: 1/260

Mills & Onello, LLP

Eleven Beacon Street, Suite 605

Boston, MA 02108

Telephone: (617) 994-4900 Facsimile: (617) 742-7774

Respectfully submitted,

Steven M. Mill

Registration Number 36,610 Attorney for Applicants Applicant(s): Min-soo Kim, et al.

## Version with Markings to Show Changes Made

## In the Specification

The paragraph at page 9 lines 14 through 26 has been amended as follows:

--N<sup>-</sup> type impurity ions are implanted into a region where n<sup>+</sup> type source and drain regions 130 and 140 will be formed, [using a mask layer pattern exposing both sides of the gate insulating layer 190 and the gate conductive layer 200] using the gate conductive layer 200 and mask layer pattern exposing both sides of the gate conductive layer 200 as ion implantation masks. After the mask layer pattern is removed, p<sup>-</sup> type impurity ions are implanted into a region where a p<sup>+</sup> type body contact region 160 and an n<sup>+</sup> type source region 130 will be formed, using a mask layer pattern exposing one side of the region and the gate conductive layer 200 as ion implantation masks. The mask layer pattern is removed and n<sup>-</sup> type and p<sup>-</sup> type impurity ions are diffused to form an n<sup>+</sup> type source region 130, an n<sup>+</sup> type drain region 140, and a p<sup>+</sup> type body contact region 160. An interlayer dielectric layer is formed, and then a portion thereof is etched to form a source contact hole 130c, a drain contact hole 140c, and a gate contact hole 200c. A source electrode 210, a drain electrode 220, and a gate electrode 230 are formed to fill the source, drain, and gate contact holes 130c, 140c, and 200c, respectively. - -

J:\SAM\0274\prelimamd.wpd